



Initial Review
BOX-1AF

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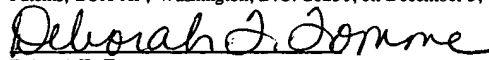
Docket: 0756-1398

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)
Takeshi FUKUNAGA et al.) Examiner M. Padgett
Serial No. 08/519,420) Art Unit 1112
Filed: August 25, 1995)
For: A METHOD OF MANUFACTUR-)
ING A SEMICONDUCTOR DEVICE)
INCLUDING LASER IRRADIATION)
FOLLOWED BY THERMAL ANNEALING) Docket No. 0756-1398

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, BOX AF, Washington, D.C. 20231, on December 3, 1996.


Deborah T. Tomme

REQUEST FOR DRAWING CHANGE APPROVAL

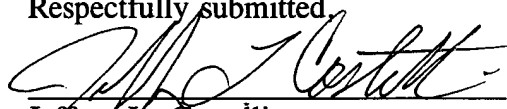
Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

The attached proposed corrections to Fig. 8 are submitted for review and approval in response to the Official Action dated September 3, 1996. The corrections, made in red ink markings, merely change the column designations to comport with the wording provided in the specification. The corrections do not add new matter and approval is requested.

Respectfully submitted,


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